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ELECTRONIC INFORMATION DISCLOSURE STATEMENT

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Title of Invention	SUPPRESSION OF LOCALIZED METAL PRECIPITATE FORMATION AND CORRESPONDING METALLIZATION DEPLETION IN SEMICONDUCTOR PROCESSING
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Application Number : 10/708, 486

Confirmation Number:

First Named Applicant: Jonathan Chapple-Sokol

Attorney Docket Number: BUR920040018US1

Art Unit: 2823

Examiner: B. KEBEDU

Search string: (6596637 or 6319833 or 6197690 or 6177349).pn

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
BU	1	6596637	2003-07-22	Schonauer et al			
BU	2	6319833	2001-11-20	Schonauer et al			
BU	3	6197690	2001-03-06	Schonauer et al			
BU	4	6177349	2001-01-23	Schonauer et al			

Signature

Examiner Name	Date
Brian Kebede	3/17/2006
